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CONFIRMATION NO. 6914

DATE 10/501,791 OT/02/2004 438 1792 039.0026 APPLICANTS Yoshifumi Kachi, Itami-shi, JAPAN; Hirohiko Nakata, Itami-shi, JAPAN; Hirohiko Nakata, Itami-shi, JAPAN; This application is a 371 of PCTJ/P03/03483 03/20/2003 **FOREIGN APPLICATIONS JAPAN 2002-309388 10/24/2002 **IF REQUIRED, FOREIGN FILING LICENSE GRANTED ** 07/28/2005 Foreign Priority daimed 1/2 Yes □ No 3S USC 110(e-t) conditions are 1/2 Yes □ No 3S U												
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APPLICANTS Yoshifumi Kachi, Itami-shi, JAPAN; Akira Kulibira, Itami-shi, JAPAN; Hirohiko Nakata, Itami-shi, JAPAN; Hirohiko Nakata, Itami-shi, JAPAN; **CONTINUING DATA **TOREIGN APPLICATIONS* JAPAN 2002-309388 10/24/2002 **IF REQUIRED, FOREIGN FILING LICENSE GRANTED ** 07/28/2005 **Foreign Priority olaimed	10.001,.0	0770222001								000.0020		
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JAPAN 2002-309388 10/24/2002 *** IF REQUIRED, FOREIGN FILING LICENSE GRANTED ** 07/28/2005 Foreign Priority claimed												
Title Ceramics FeES: Authority has been given in Paper FeES: Authority has been given in Paper See (Processing Ext. of time Paper												
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ADDRESS Judge Patent Associates Dojima Building, 5th Floor 6-8 Nishitemma 2-Chome, Kita-ku Osaka-Shi, 530-0047 TITLE Ceramics heater for semiconductor production system FILING FEE RECEIVED 920 FEES: Authority has been given in Paper No to charge/credit DEPOSIT ACCOUNT No for following: All Fees 1.16 Fees (Filling) 1.17 Fees (Processing Ext. of time 1.18 Fees (Issue) Other Other	35 USC 119(a-d) conditions met ✓ Yes □ No Verified and /SATISH CHANDRA/			ter ince	COUNTRY		AWINGS	CLAIMS		0		
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